

# Next-Generation High-Current Ion Sources for Nuclear Physics Facilities: Demonstration with Niobium and Roadmap to Heavy Ions

Institution	FY 2027	FY 2028	Total
BNL	600	500	1,100

PI: M. Okamura

Co-PI: T. Kanesue, S. Ikeda

Investigators: A. Cannavo, S. Kondrashev

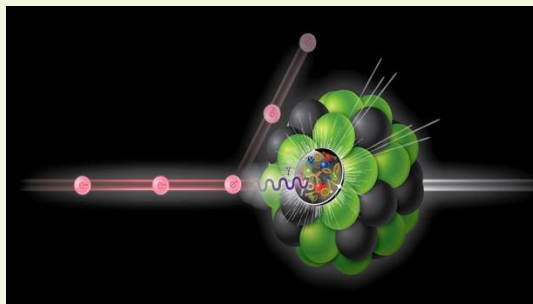


@BrookhavenLab

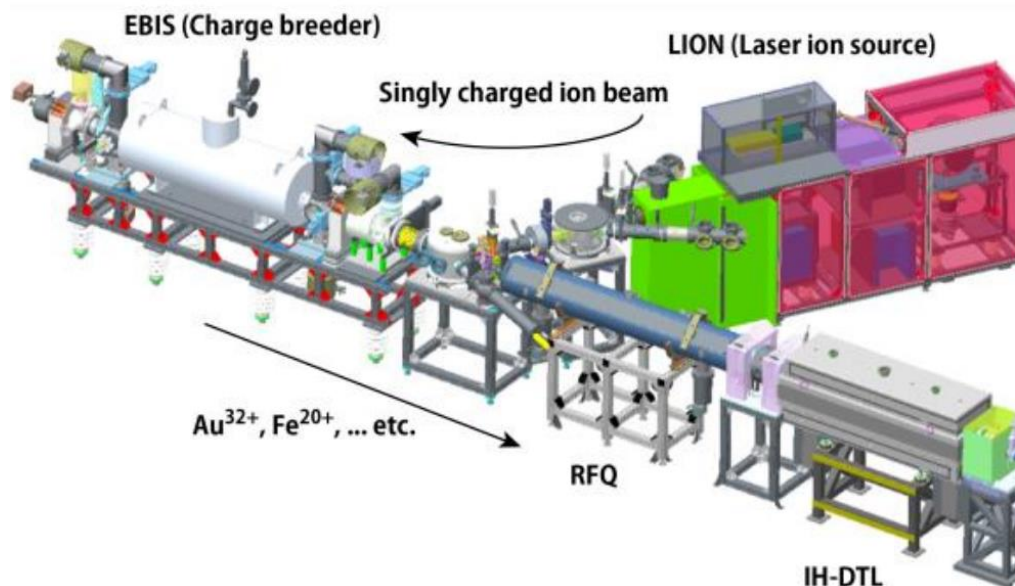
# Main Goal: Highly Charged Nb beam

## Niobium

- $Z/A = 0.440860$
- monoisotopic
- easily available
- high purity
- high melting point



Achieve most intense  
ion beam current



## EEBIS generated (@CT1):

$H^{1+}$	$1.2 \times 10^{11}$
${}^4He^{2+}, {}^4He^{2+}$	$3.5 \times 10^{10}$
$C^{5+}, O^{7+}$	$1.3 \times 10^{10}$
$Ne^{8+}$	$1.1 \times 10^{10}$
$Si^{11+}$	$7.3 \times 10^9$
$Ti^{17+}, Ti^{18+}$	$6.6 \times 10^9$
$Fe^{20+}$	$6.9 \times 10^9$
$Ag^{29+}$	$5.2 \times 10^9$
$Tb^{35+}$	$4.2 \times 10^9$
$Ta^{38+}$	$4.2 \times 10^9$
$Au^{32+}$	$6.0 \times 10^9$

and more ...

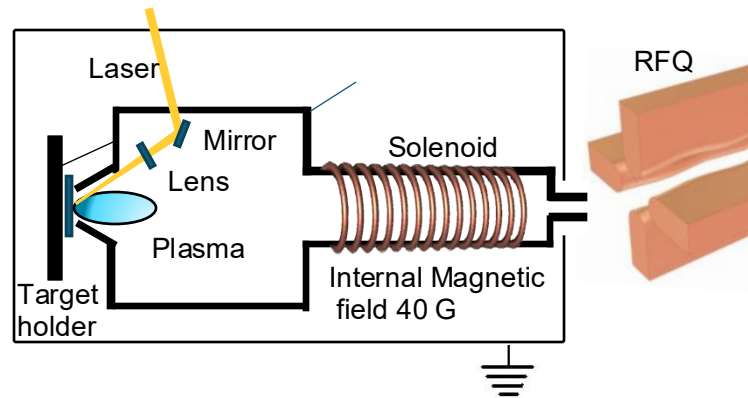
1. Theoretical limit (charge trap capacity)
2. Practical Performance limit (compensation factor, charge state distribution)

# Scientific & Technological Concept

Advances in  
Laser Technology



Direct Plasma Injection Scheme (DPIS)



Okamura, M., Takeuchi, T., Jameson, R. A., Kondrashev, S., Kashiwagi, H., Sakakibara, K., ... & Hattori, T. (2008). Direct plasma injection scheme in accelerators. *Review of Scientific Instruments*, 79(2).

Laser Energy  $\leftrightarrow$  e<sup>-</sup> Temperature  $\leftrightarrow$  Charge state

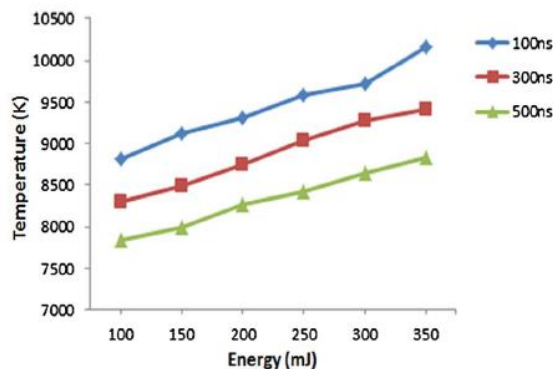


Fig. 8 Plot of the electron temperature against laser energy, at three different delay times, 100, 300 and 500 ns

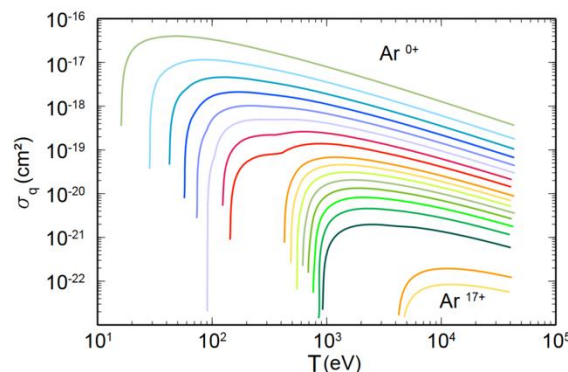


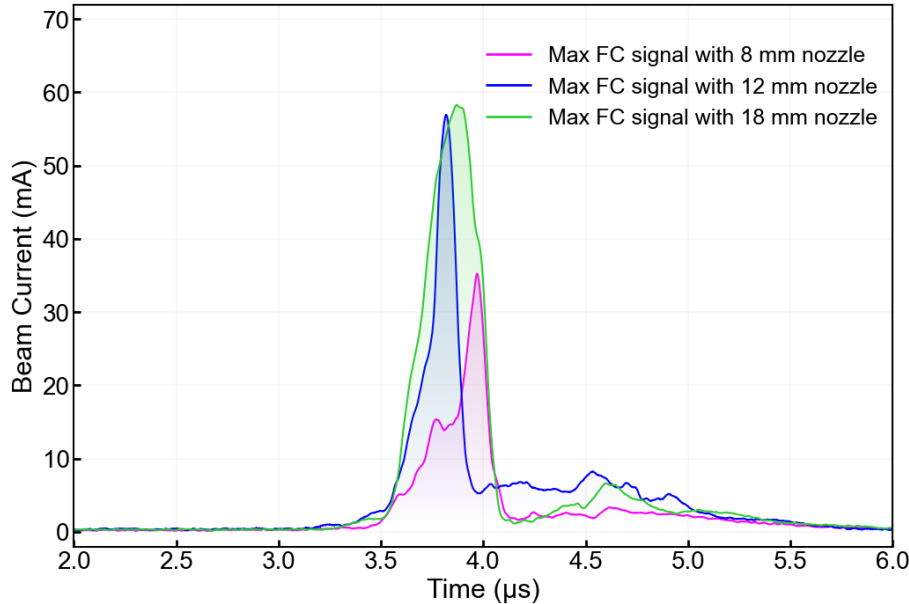
Figure 1.2.1. Electron-impact ionization cross-section of the argon atom and ions in dependence of electron energy  $T$ , (taken from [ZSCH2013]).

Asamoah, E., & Hongbing, Y. (2017). Influence of laser energy on the electron temperature of a laser-induced Mg plasma. *Applied Physics B*, 123, 1-6.

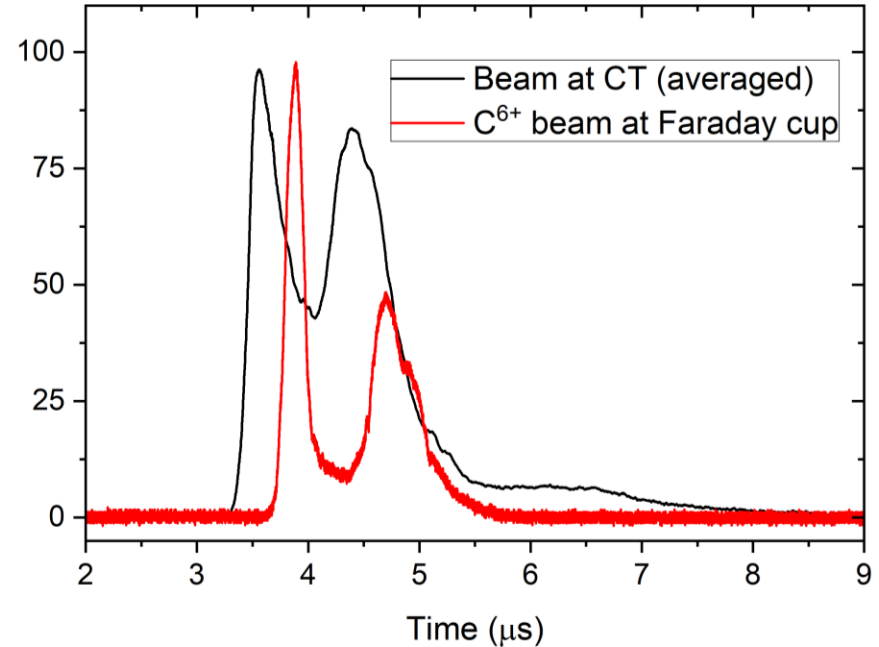
Lapierre, A., Benitez, J., Okamura, M., Todd, D., Xie, D., & Sun, Y. (2022). Ion Sources for Production of Highly Charged Ion Beams. *arXiv preprint arXiv:2205.12873*.

# The promised outcome

Achieved a new record using an aluminum ion beam.

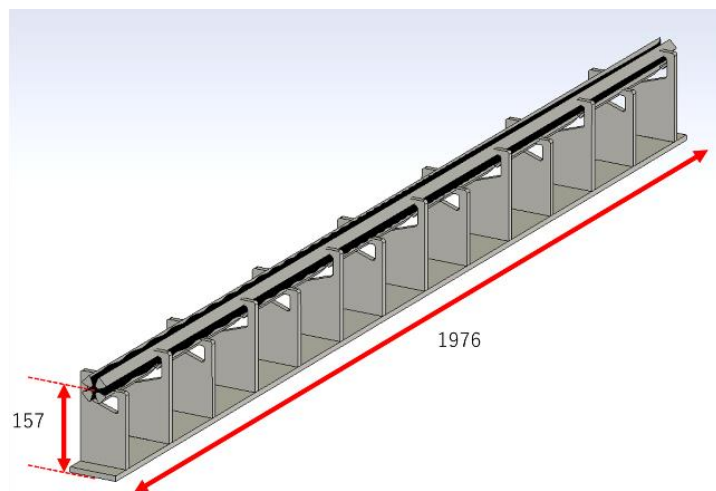


An ion current equivalent to that of the strongest class of proton ion beam

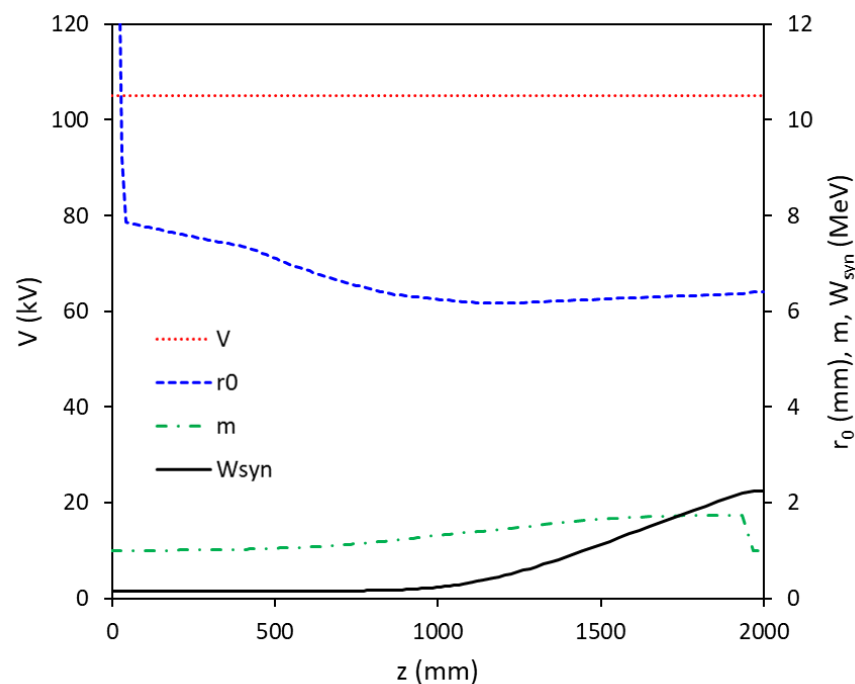


*Accelerated and analyzed beam current profile: left 58 mA  $Al^{11+}$  beam corresponding to a total  $1.0 \times 10^{10}$  ions/pulse; right 96 mA  $C^{6+}$  beam corresponding to  $4.0 \times 10^{10}$  ions/pulse.*

# World's first variable B-structure 4 rod RFQ



<b>Resonant frequency</b>	<b>100 MHz</b>
<b>Accelerated particle</b>	${}^7\text{Li}^{3+}$
<b>Peak beam current</b>	$\geq 100$ emA
<b>Input energy</b>	21.8 keV/u
<b>Output energy</b>	320 keV/u
<b>Input normalized rms emittance</b>	0.33 mmmrad
<b>Number of cells</b>	138
<b>Rod length</b>	1997.5 mm
<b>V</b>	105 kV
<b><math>r_0</math>(without RMS)</b>	6.2-7.8 mm
<b>Transverse vane-tip curvature</b>	Variable ( $\leq 1.0r_0$ )
<b><math>E_{\text{max}}</math> (Kilpatrick factor)</b>	$\leq 22.3$ MV/m (1.96)

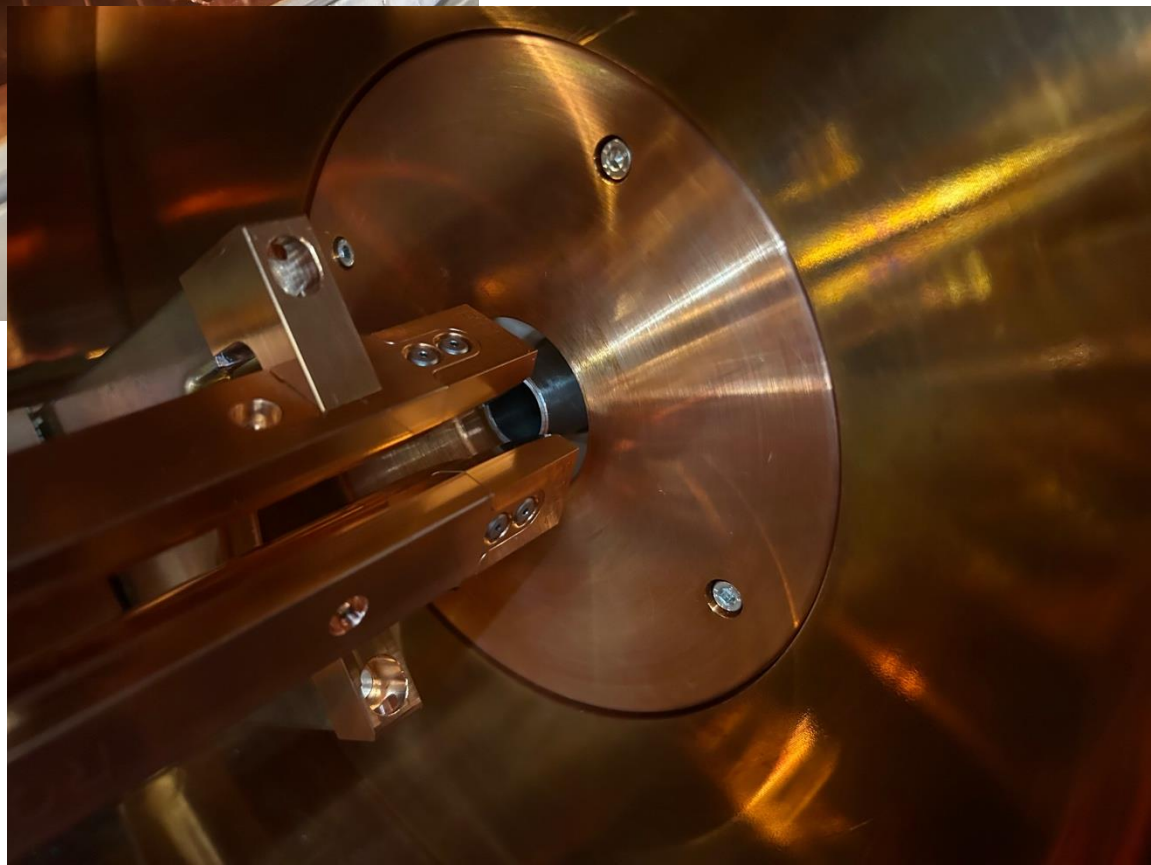




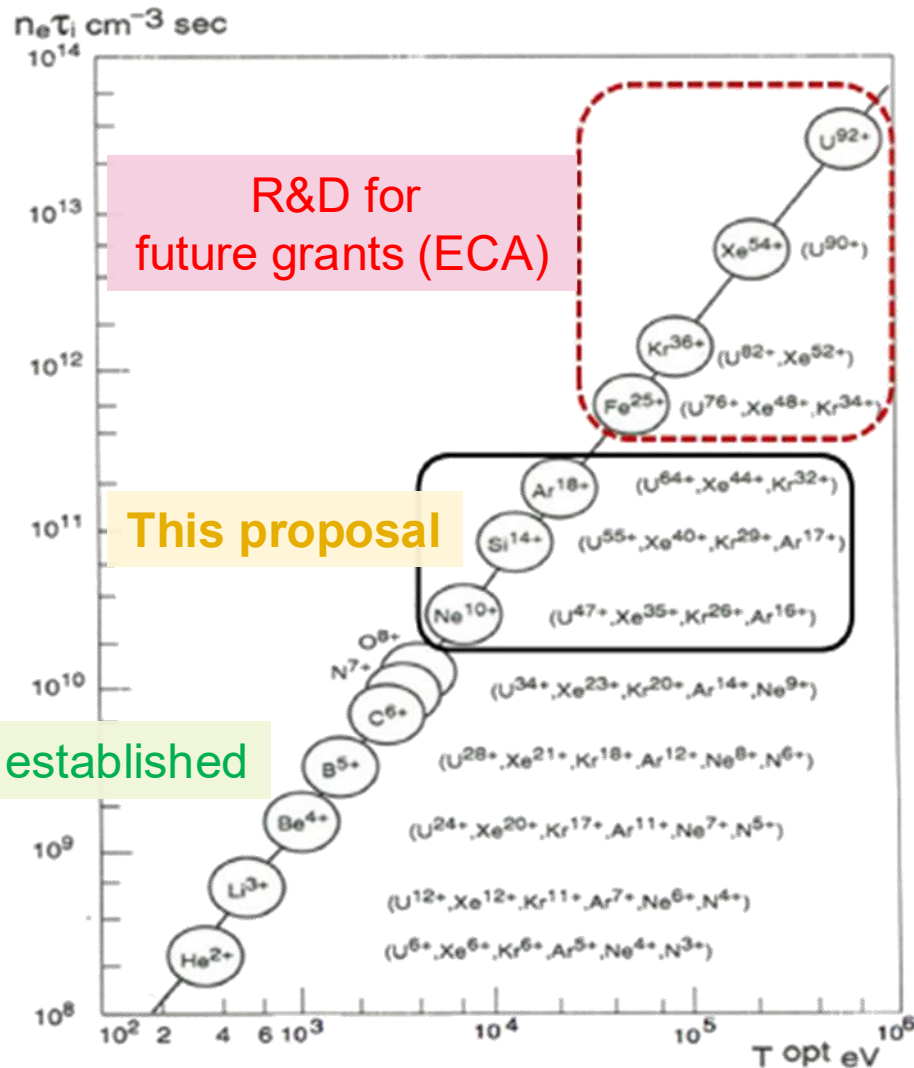


New Li vanes were commissioned and achieved full power within half a day.

250 kW

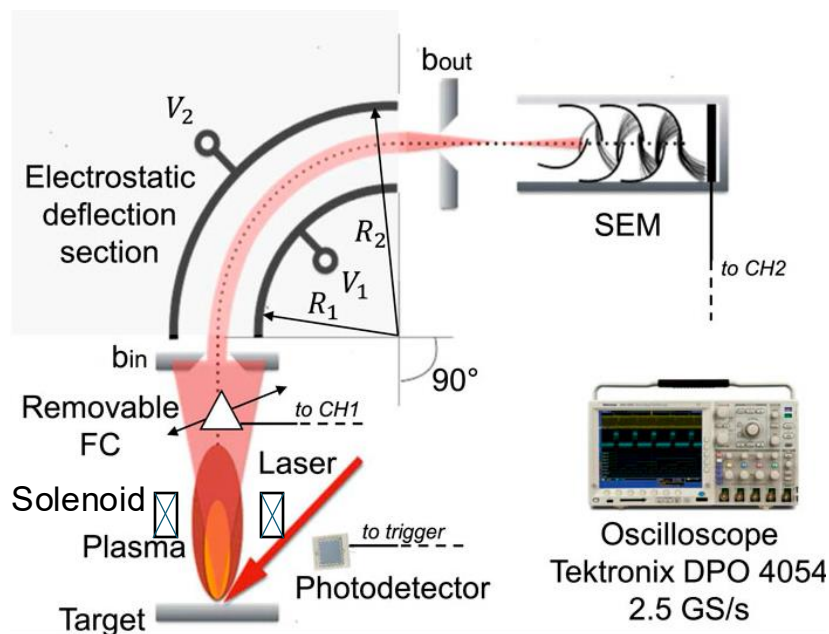


# Road map to very heavy ion



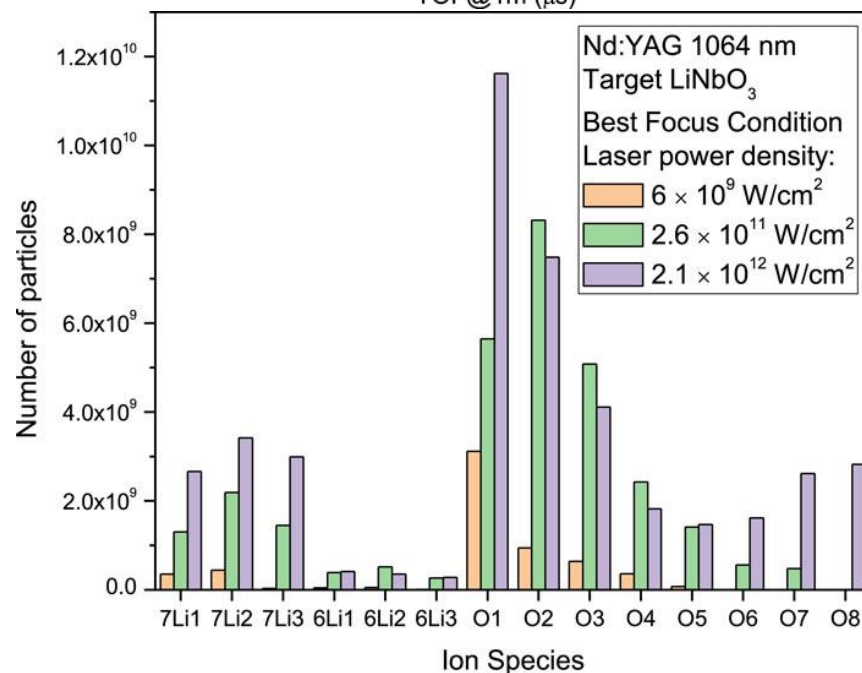
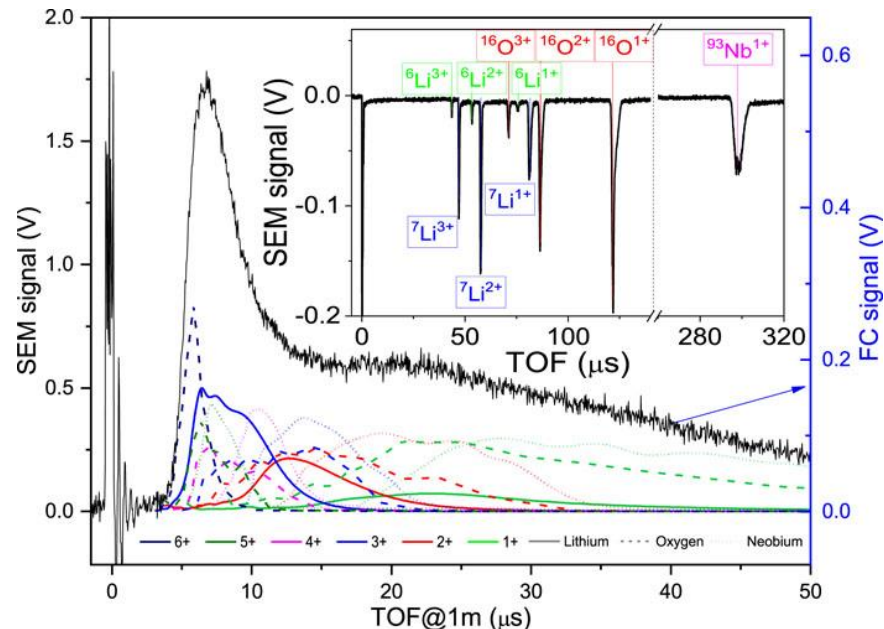
- Beneficial for the successful commissioning of the EIC
- Fundamental knowledge for the next generation of accelerator
- BNL would take a significant step forward compared to the state-of-the-art, boosting its competitiveness and leadership

# Method



Nd:YAG Laser Quantel

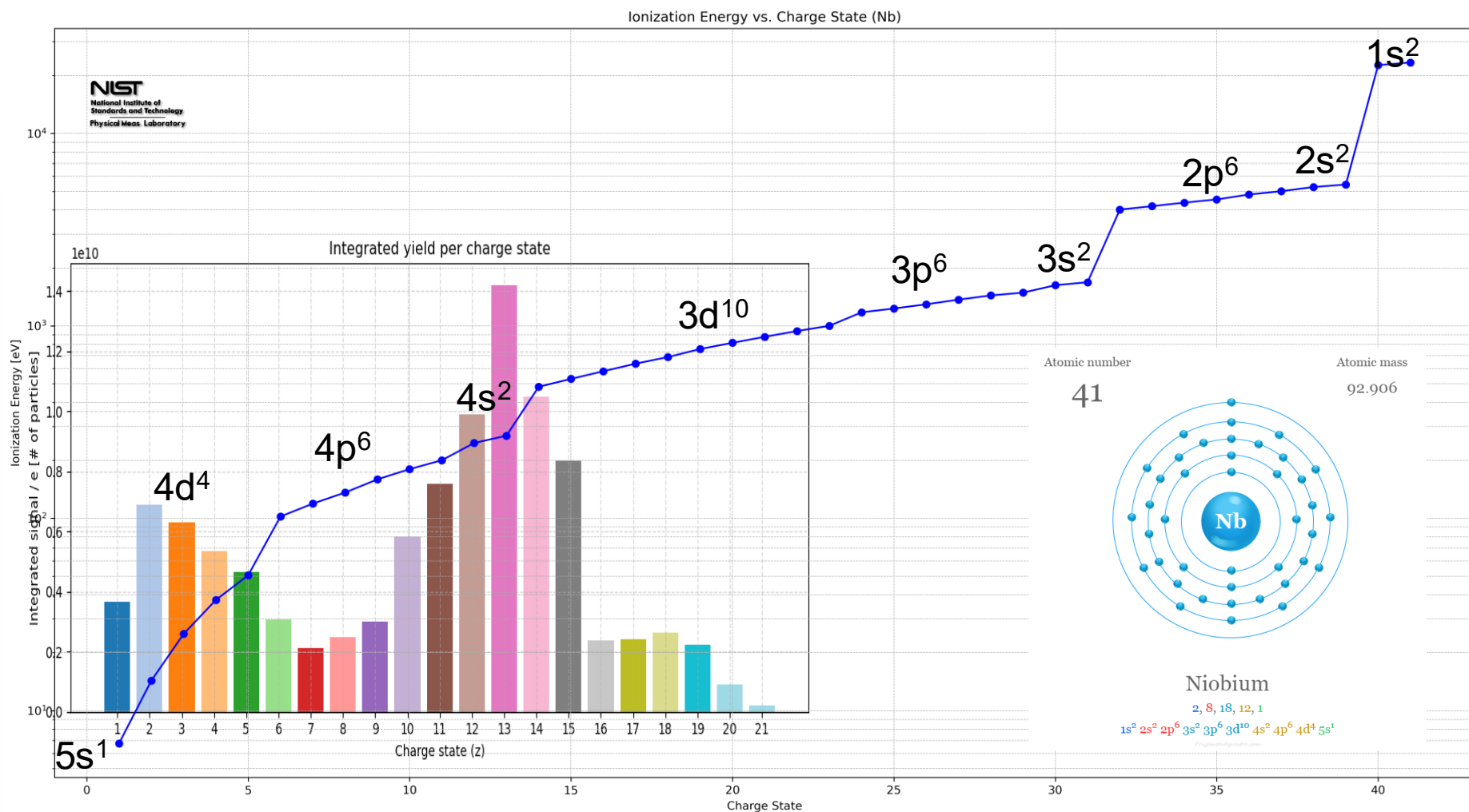
- Wavelength: 1064 nm
- Pulse energy: 850 mJ  $\rightarrow$  8 J
- Repetition rate: 5 Hz
- Pulse width: 6 ns (FWHM)
- Temporal pulse: Gaussian like





# R&D menu

- A. Plasma Study
  - A.1 Laser System Optimization
    - A.1.1 **Laser energy**
    - A.1.2 **Laser width**
    - A.1.3 **Laser incidence angle and double pulse mode**
  - A.2.1 Target surface quality control
  - A.2.2 **Advanced target development**
  
- B. Design Testing and Commissioning of the RFQ for high current Nb16+ beams
  - B.1 Design of the new set of RFQ vanes
    - B.1.1 **Plasma-RFQ Interface Optimization**
    - B.1.2 **Variable-Aperture Vane Parameter Generation**
    - B.1.3 RF Resonator Design
  - B.2. Installation and testing
    - B.2.1 Reconfiguration of the RFQ beamline
    - B.2.2 Optimization of the Solenoidal magnetic field and extraction electrode
    - B.2.3 Optimization of the RF power
    - B.2.4 Optimization of the medium-energy-beam-transport line between the RFQ and the analyzing dipole magnet
    - B.2.5 Commissioning of the Ultra-Intense Nb16+ beam production test
    - B.2.6 **Long-term stability test**



Laser Energy: 780 mJ

Task/Activity		M1-3	M4-6	M7-9	M10-12	M13-15	M16-18	M19-21	M22-24
<b>PHASE 1: PLASMA OPTIMIZATION</b>									
A.1	Procure Laser Amplifiers								
	Laser energy optimization								
	Laser width optimization								
	Laser incidence angle and double pulse mode								
A.2	Target surface quality control								
	Advanced target development								
<b>PHASE 2: RFQ DESIGN AND BEAM ACCELERATION DEVELOPMENT</b>									
B.1	Plasma-RFQ interface optimization								
	Variable-Aperture vane parameter generation								
	Resonator Design								
	Procure new RFQ vane								
B.2	Reconfiguration of the RFQ beamline								
	Optimization of the Solenoid magnet & Extraction								
	Optimization of the RF power								
	Optimization of the MEBT								
	Commissioning of the ultra-intense Nb beam								
	Long-term stability test								
<b>Dissemination and reporting</b>									
C	Conference Presentations								
	Journal Publications								

$5.0 \times 10^{10}$  Nb<sup>15+</sup> ions/pulse

# Summary

## Project's goal

- Achieving the highest intensity of highly charged Nb beam
- Overcome the EEBIS actual performance by a factor of 10
- Powerful tool, especially for EIC commissioning
- It will allow to get fundamental knowledge of laser-matter interaction and for the next generation of accelerator

## Nb beam is just a pivot species:

- Technology and achievements can be exported to uncountable number of applications and therefore attract interest from different funds source (medical isotope production....)

# **Thank you for your attention.**

We strongly hope that this proposal will be adopted.